

Notice of References Cited	Application/Control No. 10/788,616	Applicant(s)/Patent Under Reexamination FARR ET AL.	
	Examiner JAE Y. LEE	Art Unit 2466	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0018700	01-2003	Giroti et al.	709/201
*	B	US-2005/0010635	01-2005	Schwesig et al.	709/203
*	C	US-2003/0018796	01-2003	Chou et al.	709/231
*	D	US-7,107,574	09-2006	Nedbal, Manuel	717/120
*	E	US-2005/0027867	02-2005	Mueller et al.	709/227
*	F	US-2003/0033283	02-2003	Evans et al.	707/1
*	G	US-2002/0188522	12-2002	McCall et al.	705/26
*	H	US-2002/0160745	10-2002	Wang, Ray	455/404
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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